



IFW

PATENT
Attorney Docket No. 7241-31

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Koichi Hikida et al.)	Group Art Unit: 2834
)	
Application No.: 10/509,873)	Examiner: Thomas M. Dougherty
)	
Filed: October 1, 2004)	
)	
For: Inclination Sensor, Method of)	Confirmation No.: 9711
Manufacturing Inclination Sensor,)	
and Method of Measuring)	
Inclination)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REPLY TO OFFICE ACTION

In reply to the Office Action mailed July 21, 2006, please amend the
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment section of this paper.